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	Filing Date		2006-05-01	
	First Named Inventor	Ryoji FUNAHASHI		
	Art Unit			
	Examiner Name	Not yet assigned		
Attorney Docket Number		062440		

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/X.T./	4	R. Funahashi et al., "Thermoelectric properties of Ln-Ni-O (Ln : lanthanoid) system", 22nd International Conference on Thermoelectric, pages 184 to 187 (2003)	<input type="checkbox"/>
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